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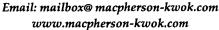
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February 27, 2006

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Applicants:

Chunyuan Chao, Kuei-Chang Tsai and George A. Kovall

Assignee:

Mosel Vitelic, Inc.

Title:

DYNAMICALLY CONTROLLABLE REDUCTION OF VERTICAL

CONTACT DIAMETER THROUGH ADJUSTMENT OF ETCH MASK

STACK FOR DIELECTRIC ETCH

Application No.:

10/718,320

Filed:

November 19, 2003

Examiner:

Deo, Duy Vu Nguyen

Group Art:

1765

Docket No.:

M-15208 US

Confirmation No.:

1058

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- This Transmittal Letter (1 page in duplicate); and
- (3) Amendment (17 pages).

No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED

		Claims Remaining After Amendment	,	Highest No. Previously Paid For		Present Extra		<u>Rate</u>		Additional Fee
Total (Claims	30	Minus	37	=	0	x	\$50.00	\$	0.00
Indepe		2	Minus	4	=	0	х	\$200.00	\$	0.00
	Fee of for the first filing of one or more multiple dependent claims per application								\$	
Fee for Request for Extension of Time									\$	0.00
Total additional fee for this Amendment:									\$	
Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.										
\boxtimes	Please charge our Deposit Account No. 50-2257 in the amount of								\$	0.00
Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257										
							T	otal:	\$	<u>0.00</u>

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 27, 2006.

Attorney for Applicant(s)

2-27-2006 Date of Signature Respectfully submitted,

Gideon Gimlan Attorney for Applicants Reg. No. 31,955



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Chunyuan ("Luis") Chao et al

Assignee:

Mosel-Vitelic, Inc.

Title:

Dynamically Controllable Reduction of Vertical Contact Diameter

Through Adjustment of Etch Mask Stack for Dielectric Etch

Application No.:

10/718,320

Filing Date:

11/19/2003

Examiner:

Deo, Duy Vu Nguyen

Group Art Unit:

1765

Docket No.:

M-15208-US

Confirm No.:

1058

San Jose, California Monday February 27, 2006

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action having a mailing date of November 25, 2005, please amend the application as set forth below.

Amendment to Specification begins on page 2 of this paper.

Claims Listing begins on page $\underline{3}$ of this paper.

Remarks begin on page 9_ of this paper.

Application No.: 10/718,320

-1-